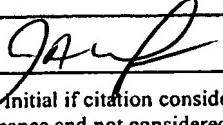


<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>	Att'y Ref: U06-052	Serial No: 10/511,359
	Applicant: HANAOKA et al.	
	Filing Date: 10/12/04	Art Unit: 3751

<b>United States Patent Documents</b>						
Examiner Initial	Document Number	Date mm/dd/yy	Name	Class	Subclass	Filing Date

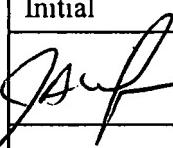
<b>Foreign Patent Documents</b>						
Examiner Initial	Publication Number	Publication Date mm/dd/yy	Country	Class	Subclass	Translation
						Yes
JAC	2350735Y	11/24/99	CN			X

Examiner: 	Date Considered: 5/23/07
EXAMINER Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered; Include a copy of this form with next communication to the applicant.	

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Examiner Initial	Publication Number	Publication Date mm/dd/yy	Country	Class	Subclass	Translation
						Yes No

Examiner Initial	Other Documents (by Title, Author Date, Pertinent Pages, Etc.)
	Office Action in Chinese Patent App. No. 03812636.2 (counterpart of present U.S. application), with English translation.

Examiner: 	Date Considered: 5/23/02
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